



Docket No. 1232-5237

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Akira KURIYAMA, et al.

Group Art Unit: 2812

Serial No.: 10/735,062

Examiner: Unassigned

Filed: December 11, 2003

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

**CORRECTED CLAIM TO CONVENTION PRIORITY**

Mail Stop \_\_\_\_\_  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application and under the provisions of 35 U.S.C. §119 and 37 C.F.R. §1.55, applicants claim the benefit of the following prior application:

Application(s) filed in: Japan  
In the name of: Canon Kabushiki Kaisha  
Serial No: 2002-363134  
Filing Date: December 13, 2002

Pursuant to the Claim to Priority, applicants submit a duly certified copy of said foreign application.  
 A duly certified copy of said foreign application is in the file of application Serial No. 10/735,062, filed December 11, 2003.

Respectfully submitted,  
MORGAN & FINNEGAN, L.L.P.

Dated: 04/26/04

By:

  
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